

## Nano4me.org Video Download

ESC 215: Nanotechnology Applications

### Unit 1: Material Fabrication Utilizing Plasma Enhanced Chemical Vapor Deposition (PECVD)



#### Lecture

**Length:** 26:52

This video will cover:

- Plasma Deposition Introduction
- Deposition Coverage
- Six Basic Steps of Chemical Vapor Deposition
- Film Growth
- PECVD Deposition Issues and Types

Thank You For Watching!

What did you think? [Email](#) Bob Ehrmann with your feedback.

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